



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Paul B. Mirkarimi et al.

Docket No. : CIL-10972

Serial No. : 10/086,614

Art Unit : 1762

Filed : March 1, 2002

Examiner : B. Pianalto

For : Ion-Assisted Deposition Techniques For  
The Planarization Of Topological Defects

APPLICATION FOR CHANGE IN CORRESPONDENCE ADDRESS

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Please change the Correspondence Address for the above-identified

application to:

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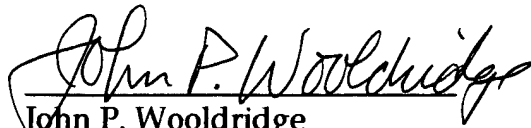
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If you have any questions, please contact the undersigned at 808-270-1011.

Respectfully submitted,

  
John P. Wooldridge  
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Dated: September 30, 2004